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Case Docket No. EWLD 16.570
Filed by Express Mail
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on 10/12/99
pursuant to 37 CFR 1.10
by Leonard

JC675 U.S. PTO
09/416839
10/12/99

S I R:

Transmitted herewith for filing is: ☒ a new application
☐ a c-i-p application of S.N. _____ filed _____

Inventor(s): Rudolf EHWALD, Karl-Ernst EHWALD, Andreas THOMAS, and Uwe BEYER

For: PROCESS FOR AFFINITY VISCOSIMETRY AND VISCOSIMETRIC AFFINITY SENSOR.

Enclosed are:

- ☒ 2 sheets of drawings. (Figs.1-2)
☒ Specification, including claims and abstract (19 pages)
☒ Declaration
☐ An assignment of the Invention to _____.
☐ A certified copy of _____ Application No. _____.
☒ An associate power of attorney
☒ A verified statement to establish small entity status under 37 CFR 1.9 and 37 CFR 1.27
☒ Post card
☐ Recording fee (as indicated below)
☐ Information Disclosure Statement, PTO-1449, copies of _____ references
☒ Other Preliminary Amendment
☐ Other _____

	Col. 1	Col. 2
FOR:	NO. FILED	NO. EXTRA
BASIC FEE		
TOTAL CLAIMS	9-20 =	11
INDEP CLAIMS	1-3 =	2
<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS PRESENTED		

*If the difference in Col. 1 is less than
zero, enter "0" in Col. 2

SMALL ENTITY	
RATE	FEE
	\$380
x 9 =	\$
x 39 =	\$
x 130 =	\$
TOTAL	\$ 380

OTHER THAN A SMALL ENTITY	
RATE	FEE
	\$760
x 18 =	\$
x 78 =	\$
x 260 =	\$
TOTAL	\$

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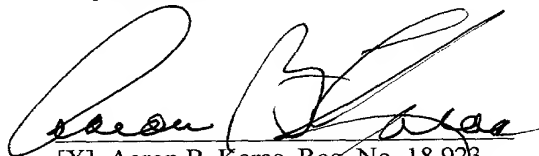
☒ A check in the amount of \$ 380.00 to cover the filing fee and the recording fee (if any) is enclosed.

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Helfgott & Karas, P.C.
60th Floor
Empire State Building
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(212)643-5000

Date: 10/12/99

Respectfully Submitted,



- ☒ Aaron B. Karas, Reg. No. 18,923
☐ Samson Helfgott, Reg. No. 23,072
☐ Leonard Cooper, Reg. No. 27,625
☐ Linda S. Chan, Reg. No. 42,400
☐ Jacqueline M. Steady, Reg. No. 44,354

Applicant or Patentee: Dr. Rudolf EHWALD Attorney's Docket No.: EWLD 16.570

Serial or Patent No.: _____

Filed or Issued: _____

For: PROCESS FOR AFFINITY VISCOSIMETRY AND VISCOIMETRIC AFFINITY SENSOR**VERIFIED STATEMENT [DECLARATION] CLAIMING SMALL ENTITY STATUS**
(37 CFR §1.9(f) and §1.27(b) - INDEPENDENT INVENTOR)

As a below named inventor, I hereby declare that I qualify as an independent inventor as defined in 37 CFR §1.9(c) for purposes of paying reduced fees under section 41(a) and (b) of Title 35, United States Code, to the Patent and Trademark Office with regard to the invention entitled PROCESS FOR AFFINITY VISCOSIMETRY AND VISCOSIMETRIC AFFINITY SENSOR described in:

☒ the specification filed herewith☐ application serial no. _____, filed _____☐ patent no. _____, issued _____

I have not assigned, granted, conveyed or licensed and am under no obligation under contract or law to assign, grant, convey or license, any rights in the invention to any person who could not be classified as an independent inventor under 37 CFR §1.9(c) if that person had made the invention, or to any concern which would not qualify as a small business concern under 37 CFR §1.9(d) or a nonprofit organization under 37 CFR §1.9(e).

Each person, concern or organization to which I have assigned, granted, conveyed, or licensed or am under an obligation under contract or law to assign, grant, convey or license any rights in the invention is listed below:

☒ no such person, concern or organization☐ persons, concerns or organizations listed below*

*NOTE: Separate verified statements are required from each named person, concern or organization having rights to the invention averring to their status as small entities. (37 CFR §1.27).

FULL NAME Karl-Ernst EHWALDADDRESS Pflaumengasse 17, 15234 Frankfurt, Germany☒ INDIVIDUAL ☐ SMALL BUSINESS CONCERN ☐ NONPROFIT ORGANIZATION

FULL NAME _____

ADDRESS _____

☐ INDIVIDUAL ☐ SMALL BUSINESS CONCERN ☐ NONPROFIT ORGANIZATION

FULL NAME _____

ADDRESS _____

☐ INDIVIDUAL ☐ SMALL BUSINESS CONCERN ☐ NONPROFIT ORGANIZATION

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I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application, any patent issuing thereon, or any patent to which this verified statement is directed.

Karl-Ernst EHWALD

NAME OF INVENTOR

K. E. Ehwald
NAME OF INVENTOR

NAME OF INVENTOR

K. E. Ehwald
Signature of Inventor

Signature of Inventor

Signature of Inventor

10.10.99
Date

Date

Date

Applicant or Patentee: Dr. Rudolf EHWALD Attorneys Docket No.: EWLD 16.570
 Serial or Patent No.: _____
 Filed or Issued: _____
 For: PROCESS FOR AFFINITY VISCOSIMETRY AND VISCOSIMETRIC AFFINITY SENSOR

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☒ the specification filed herewith
☐ application serial no. _____ filed on _____
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☐ persons, concerns or organizations listed below*

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FULL NAME Dr. Andreas Thomas
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FULL NAME _____
 ADDRESS _____
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FULL NAME _____
 ADDRESS _____
☐ INDIVIDUAL ☐ SMALL BUSINESS CONCERN ☐ NONPROFIT ORGANIZATION

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I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application, any patent issuing thereon, or any patent to which this verified statement is directed.

Dr. Rudolf EHWALD Dr. Andreas Thomas
 NAME OF INVENTOR NAME OF INVENTOR
[Signature] [Signature]
 Signature of Inventor Signature of Inventor
02.10.99
 Date Date

Applicant or Patentee: Dr. Rudolf EHWARD Attorneys Docket No.: EWLD 16.570
 Serial or Patent No.: _____
 Filed or Issued: _____
 For: PROCESS FOR AFFINITY VISCOSIMETRY AND VISCOSIMETRIC AFFINITY SENSOR

VERIFIED STATEMENT (DECLARATION) CLAIMING SMALL ENTITY STATUS
(37 CFR §1.9(f) and §1.27(b) - INDEPENDENT INVENTOR)

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☒ the specification filed herewith
☐ application serial no. _____ filed on _____
☐ patent no. _____, issued _____

I have not assigned, granted, conveyed or licensed and am under no obligation under contract or law to assign, grant, convey or license, any rights in the invention to any person who could not be classified as an independent inventor under 37 CFR §1.9(c) if that person had made the invention, or to any concern which would not qualify as a small business concern under 37 CFR §1.9(d) or a nonprofit organization under 37 CFR §1.9(e).

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FULL NAME _____
 ADDRESS _____

☐ INDIVIDUAL ☐ SMALL BUSINESS CONCERN ☐ NONPROFIT ORGANIZATION

FULL NAME _____
 ADDRESS _____

☐ INDIVIDUAL ☐ SMALL BUSINESS CONCERN ☐ NONPROFIT ORGANIZATION

FULL NAME _____
 ADDRESS _____

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I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application, any patent issuing thereon, or any patent to which this verified statement is directed.

<u>Dr. Rudolf EHWARD</u>	<u>Dr. Uwe Beyer</u>	
NAME OF INVENTOR	NAME OF INVENTOR	NAME OF INVENTOR
	<u>U. Beyer</u>	
Signature of Inventor	Signature of Inventor	Signature of Inventor
<u>R. Eward</u>	<u>22.9.1999</u>	
Date <u>22.9.1999</u>	Date	Date

Filed Via Express Mail
Rec. No.: EM366873072US
On : 10/12/99
By: [Signature]

Attorney Docket No. EWLD 16,570

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : **Rudolf EHWALD, Karl-Ernst EHWALD,
Andreas THOMAS, and Uwe BEYER**

Filed : **Concurrently Herewith**

Title : **PROCESS FOR AFFINITY VISCOSIMETRY AND
VISCOSIMETRIC AFFINITY SENSOR**

October 12, 1999

Assistant Commissioner for Patents
Washington, D.C. 20231

PRELIMINARY AMENDMENT

S I R:

Prior to the issuance of an Office Action, please amend the claims as follows:

IN THE CLAIMS:

Claim 4, line 1, please delete "claims 2 or 3" and insert -- claim 2 --.

Claim 5, line 1, please delete "claims 2 to 4" and insert -- claim 2 --.

Claim 6, line 1, please delete "claims 2 to 5" and insert -- claim 2 --.

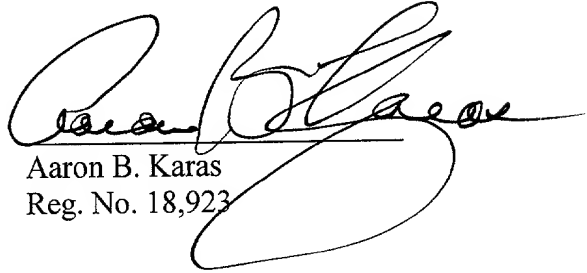
Claim 8, line 1, please delete "claims 2 to 7" and insert -- claim 2 --.

Claim 9, line 1, please delete "claims 2-8" and insert -- claim 2 --.

REMARKS

Claims 4-6, 8 and 9 have been amended to remove multiple dependencies.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Aaron B. Karas', is written over a horizontal line. Below the line, the name 'Aaron B. Karas' and 'Reg. No. 18,923' are printed. The signature is stylized with large loops and a long horizontal stroke.

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ABK.dgh:16570

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by Lenza AG

Patent application of

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SPECIFICATION

TITLE OF INVENTION

Process for affinity viscosimetry and viscosimetric affinity sensor

CROSS-REFERENCE TO RELATED APPLICATIONS

DE 1 95 01 159 A1

DE 44 40 095 A1

DE 42 03 466 A1

STATEMENT REGARDING FEDERALLY SPONSORED RESEARCH OR

DEVELOPMENT

Not applicable

REFERENCE TO A MICROFICHE APPENDIX

Not applicable

BACKGROUND OF THE INVENTION

The invention relates to the technical field of affinity assays and affinity sensors in general and of the viscosimetric principle of determination of affinity bonds in special.

BRIEF SUMMARY OF THE INVENTION

The invention makes available a process of affinity viscosimetry and a viscosimetric affinity sensor suitable for measuring the concentration of low-molecular weight affinity ligands, e. g. sugars. The general idea of the invention consists in the measurement of the analyte-sensitive flow resistance of the sensitive liquid at a high shear rate. The shear rate at viscosity measurement is at least twice the shear rate at the dialysis process. The temporal and/or spatial separation of the dialysis process from the rheological analysis enables several advantages, especially miniaturization of the implantable part of the sensor and compensation of temperature effects.

BRIEF DESCRIPTION OF THE SEVERAL VIEWS OF THE DRAWING

Figure 1. Parts of the affinity sensor. Top: Bowden cable pump with pressure sensor (1), middle: implantable sensor part with central measuring capillary and surrounding dialysis chambers, bottom: electrode chamber with electrode pairs (2) and (3) connected to the implantable sensor part.

Figure 2. Implantable sensor part made by silicon technology. The figure shows the silicon body (1), the glass cover (2), the measuring capillary (3), the electrode chamber (4), the p-conducting edges used as electrodes (5 and 6), their contacts (5a, 6a), the capacitance measuring device (7), the connections to the external data logger (7a and 7b), wall (8) and lumen (9) of the gas tubing, the hollow fiber segment (10), a glue connection (10a), the sensitive solution in the dialysis chamber (11)

DETAILED DESCRIPTION OF THE INVENTION

Viscosimetric affinity assays and related affinity sensors use the finding that a concentrated solution of a hydrocolloid and a di- or polyvalent affinity receptor, e.g. a lectin or antibody, has an analyte-dependent viscosity, if the following conditions hold: (1) the hydrocolloid exposes a structure that is similar to the analyte structure and forms affinity bonds to the receptor in the aqueous solution, (2) the concentration of the hydrocolloid is above the critical concentration for partial overlapping of the macromolecules to a network solution (Ehwald, R., Ballerstädt, R., Dautzenberg, H.: Anal. Bioch. 234, 1-8, 1996).

Known viscosimetric affinity sensors measure the convective resistance of the sensitive liquid containing the mentioned components within a hollow fiber. A known technical concept of the viscosimetric affinity sensor consists in the analysis of oscillating liquid movement in open or closed liquid-conductors (Ballerstädt R, Ehwald, R: Biosensors & Bioelectronics 9, 557-567, 1994, Ehwald, R., OS DE 1950159 A1, 1996). In these sensors the hollow fiber is part of a liquid-conductor which may contain other fluids as air or silicon oil which are used for transduction of the force to

the sensitive liquid or the measurement of the flow velocity. The dimensions of the liquid-conductor are such that the flow resistance for the mentioned additional fluid (gas or low-viscosity oil) is small in comparison to the flow resistance of the sensitive liquid within the dialysis hollow fiber. This concept requires a device for restriction of the menisci within a certain oscillation region of the liquid-conductor.

For important application fields of biosensors it is desirable to minimize the volume displacement of the matrix by the sensor as well as the change of the matrix structure due to the introduction of the sensor into the object of investigation, e.g. the tissue of a living organism. Only the dialysis chamber, e.g. a dialysis hollow fiber, must have contact with the matrix. The integration of the dialysis chamber within a closed-flow conductor for the liquid which comprises a miniaturized pump and coupling fluid (Ehwald, R., OS DE 1950159 A1, 1996) is not favourable for space restriction of those sensor parts which are in contact with the matrix. The use of flexible tubings between the pump and the dialysis chamber for separating the dialysis chamber from the pump is not compatible with a defined mid point position of the oscillating menisci. There are interfering volume changes of the oscillating sensitive liquid at prolonged measuring periods, when the oscillating system is open to the atmosphere (Ballerstädt, R, Ehwald R: Biosensors & Bioelectronics 9, 557-567, 1994).

The task of the invention is to make available a process of affinity viscosimetry and a viscosimetric affinity sensor, which are suitable for measuring time courses of the analyte concentration reproducibly. The parts of the sensor which have to be in contact with the matrix to be investigated should be of such kind that they can be replaced and introduced into a living tissue with little damage and structural change.

The technical solution of the mentioned task is a process of affinity viscosimetry and an affinity sensor according to the claims.

The invention is founded on the combination of unexpected properties of the sensitive liquids with new principles of sensor construction.

Previous concepts of the viscosimetric affinity sensors are based on the well-known experience, that colloidal aggregate structures with reversible macromolecular association are sensitive to shear forces. Their rheology is usually investigated at low shear rates (compare W.-M. Kulicke, ed., *Fließverhalten von Stoffen und Stoffgemischen*, Hüthig & Wepf-Verl. Basel, Heidelberg, New York 1986, pp. 29-31, 52-97, 88-94, 210-221). Therefore, previously mentioned affinity sensors were constructed in such a way, that an oscillating liquid flow of low amplitude and frequency is realized within the dialysis hollow fiber.

Unexpectedly, it has been found that the sensitive liquids which are liquid polymer networks structurized by affinity-cross links between dextran and Concanavalin A, respond to changes of the analyte concentration (glucose) more sensitively and reproducibly at high shear rates (5 to 1000 s^{-1}) than at lower ones. At low shear rate there is an unexpected dependence of the viscosity on the time and the previous shear treatment. The analysis of rheologic peculiarities of the sensitive liquids shows surprisingly that the viscosity of the sensitive liquids depends reproducibly on the free ligand concentration at sufficiently strong shear fields only. This enables the application of high shear rates and thereby allows of the separation of dialysis and viscosity measurement, either in spatial or temporal respect. The diffusion of the analyte into the sensitive liquid can occur before the viscosity measurement when the

sensitive liquid is not flowing at all or is streaming at low velocity and shear rate. Since the shear rate at viscosity measurement can be high, there is only a short time necessary for the measurement of the viscosity subsequent to dialysis, and this measurement can be done in a separate narrow measuring chamber.

In the claimed viscosimetric affinity sensor the dimensions of the pressure source, the dialysis chamber and eventually of the measuring chamber as well as the temporal regime of pumping are such that the shear rate at the viscosity measurement is significantly (at least two times) higher than the shear rate occurring in the dialysis chamber at the diffusional equilibration of the analyte.

Due to the claimed temporal and eventually spatial separation of dialysis and viscosity measurement the sensor can operate permanently without the need that the sensitive liquid is restricted to the dialysis fibre. The application of high shear rates facilitates the construction of an exchangeable and implantable sensor part, the surface of which is a dialysis membrane. This part, the dialysis chamber, can be integrated within a needle-like body, separately from the further parts of the liquid-conductor, and this body can be easily introduced into a living tissue. The combination of the mentioned properties allows of the construction of a device wherein the implantable sensor part is exchangeable and connected to the pump by flexible tubings or other flexible systems of mechanic force transduction.

In one variant of the claimed sensor the analyte containing sensitive liquid obtained in the dialysis chamber by diffusional equilibration with the matrix can be sucked totally or partly through a measuring chamber. It is replaced in this process by a

gas or a liquid fluid and the flow resistance of the measuring chamber is such that it dominates the whole flow resistance of this process.

If the flow resistance is controlled by a measuring chamber with comparatively small volume, the viscosity measurement can be carried out in a continuous flow with constant rate. It is essential in this case that the residence time of the flowing sensitive liquid within the dialysis chamber is sufficient for diffusional equilibration of the analyte between the external matrix and the lumen of the dialysis chamber.

Due to the applicability of high shear rates, the residence time of the sensitive liquid within the dialysis chamber can be kept small during the measuring of the flow resistance. Therefore, there is no significant retardation of the signal registration at discontinuous flow through the dialysis chamber. Alternating periods of dialysis (non or slow movement) and short periods of viscosity measurement (fast flow, high shear rate) can be applied to measure analyte-concentrations. In this case, a special measuring chamber is not necessary for the desired separation between dialysis and viscosity measurement, and a thin hollow fibre may be used as dialysis chamber and the dominating flow resistance as well.

The invention allows of several advantageous technical variants. The sensitive liquid can be pumped from a storage container through a dialysis chamber and a chamber for measuring the viscosity (flow resistance) into a final container, whereby the equilibration of the analyte in the dialysis chamber is guaranteed by the choice of an appropriate flow rate. The analyte-dependent flow resistance can be registered by different well-known principles, e.g. measuring the electrical current necessary to drive the pump with constant flow rate, by means of the pressure difference by a suitable

pressure sensor, or by measuring the velocity of liquid movement at defined pressure. Both oscillating and stationary flow of the liquid are applicable.

To reduce the flow resistance in the tubings outside the dialysis and measuring chambers, a gas, a gas mixture or a nonaqueous transport fluid of low viscosity can be introduced into the liquid-conductor. In this case two steps can be involved in the measuring process: 1. equilibration of the sensitive liquid in the dialysis chamber with the matrix to be investigated, 2. introduction of the low-viscosity fluid into the liquid-conductor close to the dialysis chamber, thereby moving the equilibrated sensitive liquid from the dialysis chamber through the measuring chamber with sufficiently high shear rate. The second step allows of the measurement of the analyte-dependent viscosity.

The dialysis chamber can be constructed in such a way that it consists of the space between a solid body and the dialysis membrane. The dialysis chamber can be made from segments of a commercial dialysis hollow fiber that surrounds a thin capillary as usual in microdialysis. The enclosed capillary can be used as measuring chamber.

When the flow resistance is measured by the electrical current or the electrical power at constant flow rate the pump is constructed and controlled in order to create a flow rate that is independent of the flow resistance, e.g. a pump with a piston that is combined with a threaded rod driven with high step-down ratio by an electromotor. Possible variants of the sensor have a pump that sucks at one face of the liquid-conductor and pumps at the other face. Besides the mentioned types of pumps others,

e.g. dielectric or magnetic ones, gas pumps, or pumps driven by the force of a spring can be applied.

The flow resistance of the flowing sensitive liquid in the measuring chamber can be determined by measuring the time necessary for the movement of a defined volume. The latter measuring principle can be realized by measuring the time for the movement of a gas-liquid meniscus between two electrical or optical marks. If the direction of the pressure difference is altered at reaching the mark by a suitable electronic control system, the movement of the meniscus can be restricted to a segment of the liquid-conductor between electrical or optical marks. In this case, an oscillating movement of a part of the sensitive liquid from the dialysis chamber(s) into and through the measuring chamber can be obtained. At defined pressure difference, the duration of the oscillation period is proportional to the flow resistance of the sensitive liquid in the measuring chamber.

As high shear forces are compatible with the principle of the viscosimetric affinity sensor, the measuring chamber can be kept narrow and short. Therefore, it is possible to keep the flowing volume very small and to choose a short measuring chamber with high resistance for viscous flow. This enables a special variant of the sensor, where the dialysis fiber is connected to a blind end of the liquid-conductor at one face and with the measuring chamber and pump at the other face. When the volume flow resistance of the dialysis membrane is comparable or higher than the flow resistance of the measuring chamber, it is necessary to ensure a sufficiently high elastical volume capacity of the blind ending part of the liquid-conductor. A sufficient

volume capacity of the blind ending part can ensure that the flow is controlled by the viscous resistance in the measuring chamber.

The invention will be specified by the following examples

A) The sensor contains the following parts: an electromotor with threaded rod and Bowden cable, a pumping vessel containing the sensitive liquid and a pressure sensor (Fig. 1, above), a dialysis needle (Fig. 1, middle part) and a tank for collecting consumed sensitive liquid. The electromotor drives a threaded rod with high step-down ratio and thereby moves the wire of the Bowden cable into the pumping vessel or out of it. The pumping vessel consists of ceramics or another very stiff material and is separated into two chambers by a highly flexible membrane. One chamber contains a pressure sensor (1) and is filled with gas-free silicon oil. This chamber is connected with the Bowden cable. The other chamber is filled with the sensitive liquid (e.g. a solution of 70 mg/ml Dextran T2000 and 10 mg/ml Concanavalin A) and is connected with the dialysis needle by a ca. 10 mm long polypropylene tubing. The sensitive liquid in the pumping chamber may contain the analyte (e.g. glucose) in a concentration which is typical for the investigated matrix. The dialysis needle (Fig. 1, middle part) contains, as usual for microdialysis, a capillary that is enclosed within a dialysis chamber or dialysis chambers. The cross-sectional area of the dialysis chamber(s) is significantly larger than that of the capillary lumen. The dialysis chamber is connected with the collecting tank for the sensitive liquid by short tubing. The collecting vessel is a short polypropylene tube containing self-sucking porous material, e.g. cotton. It is open to the atmosphere. The dialysis needle has a higher flow resistance than the tubings.

This variant of the sensor allows of the following measuring process. In the first step the metal wire of the Bowden cable is pushed into the silicon oil of the pumping vessel rapidly and as far as necessary to allow of a complete replacement of the sensitive liquid in the dialysis chamber. The speed of this step is such that a well measurable pressure increase is measured by the pressure sensor. The time course of the pressure signal during the pumping process and/or its relaxation is analyzed electronically. After a dialysis time of ca. 2 min the metal wire is redrawn for a short extent. Preferably, the extent of this backward volume displacement is smaller than that at the inward displacement. By comparing the pressure signals at inflow into the dialysis chamber (known analyte concentration in the measuring capillary) and backflow out of the dialysis chamber (analyte concentration in the measuring chamber equal to that of the matrix), it is possible to determine the analyte concentration in the matrix from a calibration curve. The reference to a prefixed value of the analyte concentration renders temperature compensation unnecessary. As inward pumping strokes induce a larger flow than backward strokes, the dialysis chamber is filled with new sensitive liquid of standard glucose concentration at the beginning of each measuring cycle.

B. The liquid-conductor of the sensor consists of the following components in series: a pump and a dialysis needle as in A, an electrode chamber (Fig. 1, bottom), a collecting tank for the consumed sensitive liquid, a low-pressure chamber, and a gas pump. The electrode chamber is localized between the dialysis chamber and the collecting tank for the consumed sensitive liquid, the measuring capillary between the dialysis chamber and the pump. One polypropylene tubing connects the measuring

capillary with the pumping vessel for the sensitive liquid, another one connects the electrode chamber with the collecting tank for consumed sensitive liquid. The collecting tank and the pumping vessel with the Bowden cable are similar as explained in example A; however a pressure sensor is not necessarily involved. There are valves which can be used to connect the collecting tank either with the low-pressure reservoir or the atmosphere. The low-pressure reservoir is kept at defined gas pressure below the atmosphere value by means of the gas pump. Close to the measuring capillary the polypropylene tubing connecting the pumping vessel with the measuring chamber in the dialysis needle is narrow (inner diameter ca. 200 μm). At this place the tubing wall is perforated by narrow pores. The electrode chamber has a diameter of ca. 200 μm . Its inner wall contains two pairs of electrically insulated electrodes in a defined distance. The capacity measured at these electrode pairs responds to movement of the meniscus through the electrode chamber.

This variant of the sensor allows of the following measuring process: The collecting tank is set to atmospheric pressure. A small amount of the sensitive liquid will be driven by the pump through the dialysis needle and the electrode chamber into the collecting tank. Subsequently the liquid column is moved slowly backward until the meniscus reaches the first electrode pair (2) of the electrode vessel. The obtained capacitance signal is used to interrupt the pump activity. After a dialysis time of about 3 min the valve to the atmosphere is closed and the collecting vessel set to defined low-pressure by opening the valve to the low-pressure chamber. This way the liquid column is set under tension and air enters into the sensitive liquid at the porous site of the tubing wall. Subsequently a small amount of the sensitive liquid is separated from

its reservoir in the pumping vessel and moves through the dialysis needle towards the collecting tank. The time between the opening of the valve to the low-pressure reservoir and the movement of the meniscus through the site of the second electrode pair is a measure for the analyte-dependent viscosity of the sensitive liquid after the dialysis. The whole separated portion of the sensitive liquid is driven into the collecting vessel. After a time sufficient for this process, the next measuring cycle is prepared. For this purpose the collecting vessel is set to atmosphere pressure and the liquid conductor is refilled by the Bowden cable pump.

C: The fluid conductor of the sensor contains the following parts in series: a pumping vessel for the sensitive liquid, a branched tubing, an electrode chamber, a dialysis needle and a collecting tank connected by valves with the atmosphere or a gas pressure source consisting of a chamber with reduced or increased gas pressure, and a gas pump.

The pumping vessel for the sensitive liquid, the electrode chamber, the dialysis needle and the collecting vessel are constructed in the same kind as described in examples A and B. The dialysis needle is connected with the polypropylene tubings in such a way that the dialysis chamber is next to the collecting tank and the electrode chamber next to the measuring capillary. In a short distance to the electrode chamber there is a short branching of the polypropylene tubing with a valve, by means of which the liquid column can be set under atmospheric pressure. The electrode space is situated between the measuring capillary and the branching. The volume between the electrodes is comparable to the volume of the dialysis chamber. The dialysis chamber is connected by short distance with the collecting vessel. The polypropylene tubing

between the gas-pressure source and the collecting vessel contains valves by which it can be connected either with the pressure source or the atmosphere.

This variant of the sensor allows of the following measuring process:

The pumping device drives a small amount of the sensitive liquid, about twice the volume of the dialysis chamber, with low rate into the collecting tank, whereby the gas-entry valve at the branching is closed and the tubing between collecting tank and the gas pressure source is at atmospheric pressure. Meanwhile the gas reservoir is set at a defined pressure below atmosphere by the use of a gas pump. Thereafter the gas entry valve at the branching and the valve between the gas pressure source and the collecting vessel are opened. Air enters into the tubing at the branch, and the meniscus is driven through the electrode space towards the collecting tank. The time necessary for the movement of the meniscus between the electrode pairs is proportional to the flow resistance of the sensitive liquid in the measuring capillary before its equilibration with the matrix. When the meniscus has reached the electrode pair close to the measuring capillary, the obtained capacitance signal is used to set the liquid column to the atmospheric pressure, whereby the liquid column is stopped. During the dialysis time of ca. 2 min a defined over-pressure is created in the gas pressure chamber. Subsequently the gas pressure source is connected with the liquid column again, whereby the meniscus is driven back through the measuring capillary. Now the sensitive liquid flowing through the measuring capillary is modified by the analyte of the matrix. Preferably, in this arrangement the sensitive liquid in the reservoir of the pumping vessel contains the analyte in a defined reference concentration. The deviation from this concentration can be obtained by the ratio of the displacement

times in both directions of liquid movement. As the ratio of the affinity-mediated viscosities at different analyte concentrations is little dependent on temperature, this variant of the affinity sensor gives accurate data even without thermostating. Finally the valve at the branche is closed and the next measuring cycle prepared by pumping fresh sensitive solution towards the collecting tank.

D. The sensor needle (Fig. 2) is made by semiconductor technology: It contains a blind ending dialysis chamber realized by a hollow fiber segment (10), a measuring capillary (3) and a capacitance measuring chamber (4) with suitable electrodes (5). The n-conducting, ca. 200 μm thick, 0.5 mm wide, and 20 mm long silicon substrate (1) contains a V-edged threeangular furrow (3, 4) and is bonded gas- and water-tightly with a fitted covering plate consisting of boron silicon glass (2). A part of the furrow (at 4) is deeper than the other one (at 3). Both parts form, together with the covering plate, a capillary with a threeangular cross-section. The inner wall of the capillary is completely covered with SiO_2 by thermic oxidation of the silicon substrate after the V-edging. The cross-sectional area of the capillary of the deeper furrow (4) is about 5 times larger than that of the flatter one (3). The edge of the deeper furrow is formed by p-conducting zones (5) and (6). The p-conducting zones are separated from each other by the furrow and the n-conducting silicon substrate and contain contacts (5a) and (6a), which are connected with a capacitance measuring device (7). The narrow furrow used as measuring capillary (3) is open by windows in the silicon body to the blind ending dialysis chamber (11). The dialysis chamber, the measuring capillary (3) and a part of the electrode chamber (4) are filled with the sensitive liquid. The dialysis fiber segment (10) is tightly glued with the needle body (10a). The electrode capillary (4) is

connected by a thin gas tubing (8, 9) to a gas pump that is able to create pressure differences to the atmosphere (-0.09 to + 0.3 MPa). The needle-like sensor such described can be fitted into a cannula and this way introduced into the matrix, e.g. a living tissue.

This variant of the sensor allows of the following measuring process: By application of a gas pressure of ca. + 0.3 MPa the sensitive liquid is moved within some seconds (< 10 s) from the electrode space into the dialysis chamber until the meniscus reaches the measuring capillary, whereby water is extruded through the hollow fiber membrane, and the dialysis chamber is elastically stretched. At emptying of the electrode space, the capacitance between the contacts (5a) and (6a) is falling below an incipient value. This is the signal to change the pressure to a below-atmosphere value (ca. -0.08 MPa), whereby the electrode chamber is refilled. When the maximum capacitance is reached, the direction of the gas pressure is changed again and the electrode space is emptied. The speed or the frequency of filling the electrode chamber registered by the change of the capacitance depends on the glucose concentration in the dialysis chamber. In order to prevent differences in the glucose concentration between measuring and dialysis chamber, a repeated filling and emptying of the measuring chamber is recommended.

CLAIMS

We claim:

1. A process for measuring analyte concentrations by affinity viscosimetry consisting in pumping of the sensitive liquid through a conductor for streaming liquids with integrated dialysis chamber and measuring device for viscosity, whereby the maximum shear rate of the sensitive liquid, which occurs at the measuring process, is at least twice the maximum shear rate of the sensitive liquid occurring in the dialysis chamber during the dialysis process.
2. A viscosimetric affinity sensor for carrying out a process according to claim 1, characterized by a liquid-conductor perfusable by the sensitive liquid and containing a dialysis chamber, a measuring chamber for the flow resistance and a connected pumping device, whereby the flow resistance of the measuring chamber is layed out such that the maximum shear rate in the sensitive liquid during the measuring process is more than twice the maximum shear rate occurring in the sensitive liquid during the dialysis process.
3. A viscosimetric affinity sensor according to claim 2, characterized by the following peculiarity: the dialysis chamber is part of a needle-like body.
4. A viscosimetric affinity sensor according to claims 2 or 3, characterized by the following peculiarity: the liquid-conductor contains a pressure sensor.

5. A viscosimetric affinity sensor according to one of the claims 2 to 4, characterized by the following peculiarity: the measuring chamber is situated within a needle-like body, the dialysis chamber is situated at its surface.

6. A viscosimetric affinity sensor according to one of the claims 2 to 5, characterized by the following peculiarity: the sensitive liquid fills the dialysis chamber and the measuring chamber, and borders within the measuring chamber or within an additional chamber to a fluid of low viscosity which is not miscible with water.

7. A viscosimetric affinity sensor according to claim 6, characterized by the following peculiarity: the additional chamber contains one or more electrodes, by the help of which the position of the meniscus between fluid and sensitive liquid can be followed.

8. A viscosimetric affinity sensor according to one of the claims 2 to 7, characterized by the following peculiarity: the sensor contains a valve or a valve-like device for interruption of the cohesion within the sensitive liquid by introduction of a gas or another fluid with low viscosity, whereby this valve or valve-like device is placed between the dialysis chamber and the measuring chamber or between the dialysis chamber and the pump.

9. A viscosimetric affinity sensor according to one of the claims 2-8, characterized by the following peculiarity: the lumen of the dialysis chamber consists of a space between a solid body and the dialysis membrane.

ABSTRACT OF THE DISCLOSURE

The invention concerns a process for affinity viscosimetry and a viscosimetric affinity sensor on the basis of sensitive liquids with analyte-dependent viscosity which are localized within a perfusable dialysis chamber and contain colloidal constituents which are cross-linked by affinity bonds. The viscosimetric affinity sensor according to this invention is characterized by the spatial or temporal separation of analyte diffusion from the measurement of the flow resistance. An important advantage of the invention consists in small volume-displacement and negligible structural change within the matrix to be investigated.

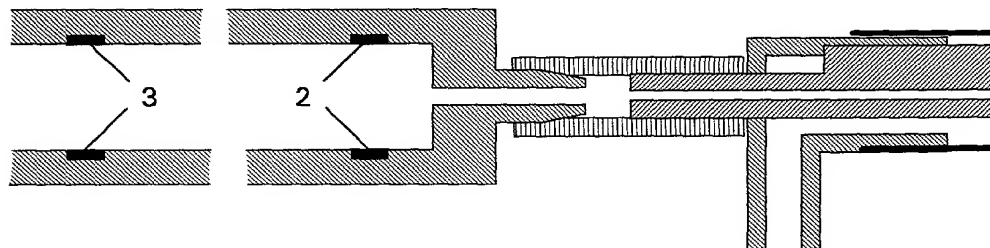
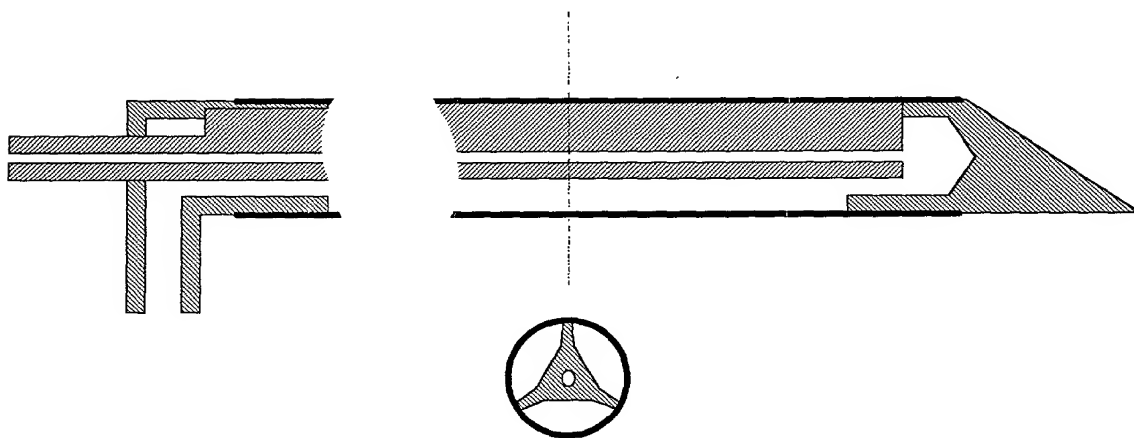
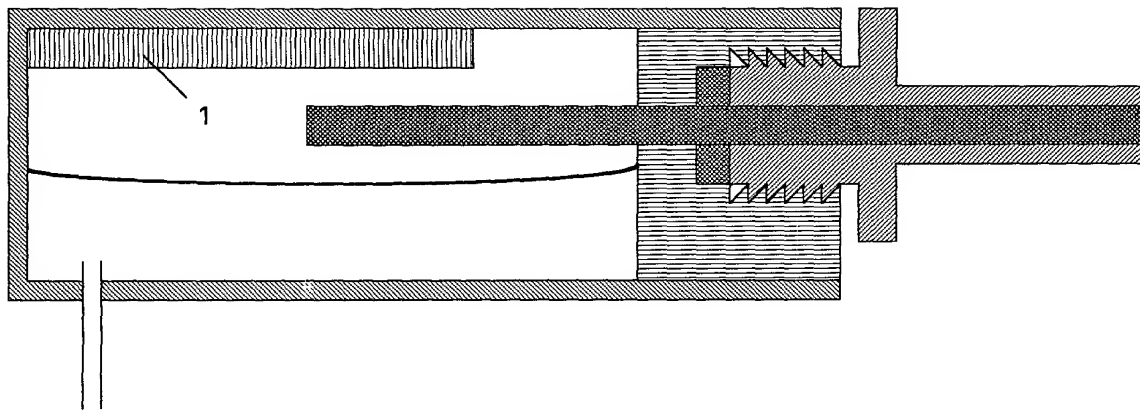


Figure 1

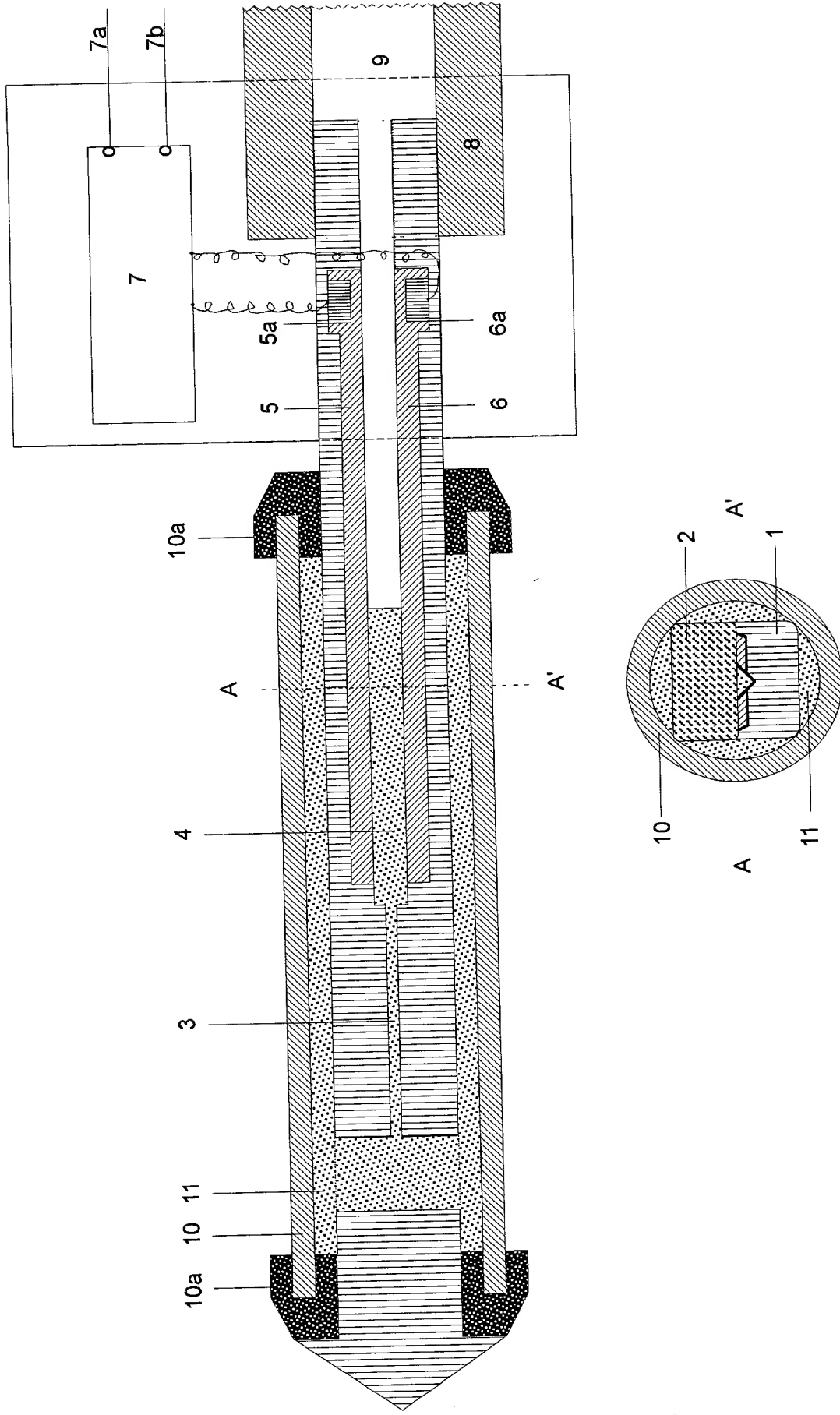


Figure 2

UNITED STATES

DECLARATION FOR PATENT APPLICATION

Docket No. EWLD 16.570

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.
 I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:
PROCESS FOR AFFINITY VISCOSIMETRY AND VISCOSIMETRIC AFFINITY SENSOR.

the specification of which

(check one) ☒ [X] is attached hereto☐ [] was filed on _____ as

Application Serial No. _____ and was amended on _____ (if applicable).

I hereby state that I have reviewed and understand the contents of the above-identified specification, including the claims, as amended by an amendment referred to above.

I acknowledge the duty to disclose information which is material to the examination of this application in accordance with Title 37, Code of Federal Regulations §1.56(a).

I hereby claim foreign priority benefits under Title 35, United States Code, §119 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

Prior Foreign Application(s)

Priority Claimed

Yes No

(Number)

(Country)

(Day/Month/Year Filed)

Yes No

(Number)

(Country)

(Day/Month/Year Filed)

Yes No

(Number)

(Country)

(Day/Month/Year Filed)

I hereby claim the benefit under Title 35, United States Code §120 of any United States application(s) listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code, §112, I acknowledge the duty to disclose material information as defined in Title 37, Code of Federal Regulations §1.56(a) which occurred between the filing date of the prior application and the national or PCT international filing date of this application:

(Application Serial No.)

(Filing Date)

(Status-patented, pending, abandoned)

(Application Serial No.)

(Filing Date)

(Status-patented, pending, abandoned)

I hereby appoint as my attorney and agent Aaron B. Karas, Reg. No. 18,923, Samson Helfgott, Reg. No. 23,072, Leonard Cooper, Reg. No. 27,625, Linda S. Chan, Reg. No. 42,400 and Jacqueline M. Steady, Reg. No. 44,354 to prosecute this application and to transmit all business in the Patent and Trademark Office connected therewith.

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I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

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Filed: : Concurrently herewith

For : PROCESS FOR AFFINITY VISCOSIMETRY AND VISCOSIMETRIC
AFFINITY SENSOR

Serial No.: Concurrently herewith

October 12, 1999

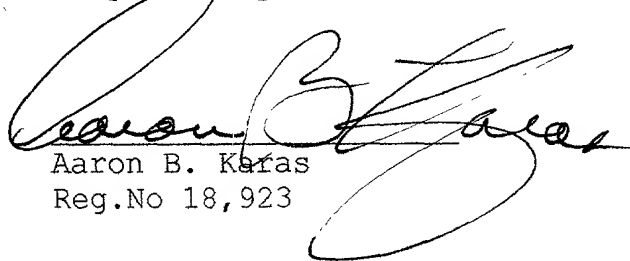
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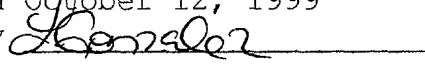
S I R:

I, Aaron B. Karas Reg. No. 18,923 attorney of record herein,
do hereby grant a sub-power of attorney to Harris Wolin, Reg. No.
39,432 to act and sign in my behalf in the above-referenced
application.

Respectfully submitted,


Aaron B. Karas
Reg.No 18,923

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